




IFW

PATENT
Docket No. 20067/OPP040601US

**IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE**

Applicant(s):)	I hereby certify that this paper and the
)	documents referred to as enclosed
Geon-Ook Park)	therewith are being deposited with the
)	United States Postal Service as first
U.S. Serial No.: 10/817,096)	class mail, postage prepaid, in an
)	envelope addressed to Commissioner
For: "Semiconductor Device and)	for Patents, P.O. Box 1450,
Fabrication Method Thereof")	Alexandria, Virginia 22313-1450 on
)	this date:
Filed: April 2, 2004)	
)	March 31, 2005
Group Art Unit: 2811)	
)	
Examiner: Not yet assigned)	
)	Mark G. Hanley
)	Attorney for Applicant(s)
)	Registration No. 44,736

STATUS LETTER

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

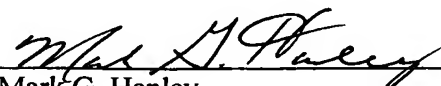
Kindly advise when an Office action can be expected in the above-referenced matter. Please note that it has been more than eight months since the last communication.

Respectfully submitted,

HANLEY, FLIGHT & ZIMMERMAN, LLC
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Chicago, Illinois 60606
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March 31, 2005

By:


Mark G. Hanley
Registration No.: 44,736